

JAN 03 2006

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FACSIMILE COVER SHEET

January 3, 2006

Receiver: Examiner Picardat, Kevin M. / Art Unit 2822
USPTO

FAX #: 571-273-8300

Sender: Leslie Russell, Patent Secretary for:
Jeffrey K. Weaver- Reg No. 31,314

Our Ref. No.: NOVLP089/NVLS-2886/2887

Your Ref No.: 10/800,377

Re: Response to Restriction Requirement

Pages Including Cover Sheet(s): 3

MESSAGE:

Fax Cover Sheet – 1 Page
Amendment Transmittal – 1 Page
Response to Restriction Requirement – 1 Page

CONFIDENTIALITY NOTE

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JAN 03 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cho et al.

Atty Docket No.: NOVLP089/NVLS-
2886/2887

Application No.: 10/800,377

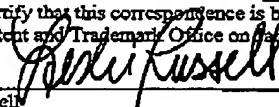
Examiner: Picardat, Kevin M.

Filed: March 11, 2004

Group: 2822

Title: METHOD AND APPARATUS FOR UV
EXPOSURE OF LOW DIELECTRIC
CONSTANT MATERIALS FOR POROGEN
REMOVAL AND IMPROVED MECHANICAL
PROPERTIES**CERTIFICATE OF FACSIMILE TRANSMISSION**

I hereby certify that this correspondence is being transmitted by facsimile to Examiner Picardat, Kevin M. at fax number 571-273-8300 to the U.S. Patent and Trademark Office on January 3, 2006.

Signed: 
Leslie Russell**AMENDMENT TRANSMITTAL**Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

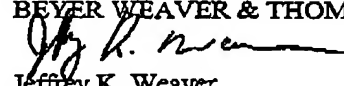
Sir:

Transmitted herewith is a Response to Restriction Requirement in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	40	MINUS	53	0	x 25 =	x 50 = 0.00
Independent Claims	3	MINUS	3	0	x 100 =	x 200 = 0.00
Multiple Dependent Claim Present and Fee Not Previously Paid						
Total					\$	\$0.00

- ☐ Applicant(s) hereby petition for a _____ month extension(s) of time to respond to the aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☐ Enclosed is our Check No. _____ in the amount of \$ _____ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. NOVLP089).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLP
Jeffrey K. Weaver
Reg. No. 31,314P.O. Box 70250
Oakland, CA 94612-0250

JAN 03 2006

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Cho et al.

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2886/2887

Application No.: 10/800,377

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EXPOSURE OF LOW DIELECTRIC CONSTANT
MATERIALS FOR POROGEN REMOVAL AND
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Signed: 

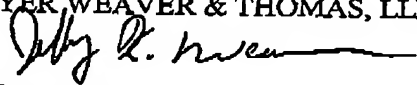
Leslie Russell

RESPONSE TO RESTRICTION REQUIREMENTCommissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Restriction Requirement dated December 14, 2005, Applicants hereby elect, without traverse, Group I, claims 1-40 to prosecute in the above-identified patent application.

If any fees are due in connection with the filing this Response to Restriction Requirement, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP089).

Respectfully submitted,
BEYER, WEAVER & THOMAS, LLP
Jeffrey K. Weaver
Registration No. 31,314P.O. Box 70250
Oakland, CA 94612-0250